



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

RCE

In re application of : Confirmation No. 1632
Norio KIMURA et al. : Attorney Docket No. 2001-0660A
Serial No. 09/864,208 : Group Art Unit 1763
Filed May 25, 2001 : Examiner Jeffrie R. Lund
SUBSTRATE POLISHING APPARATUS AND : Mail Stop: RCE
SUBSTRATE POLISHING METHOD

PATENT OFFICE FEE TRANSMITTAL FORM

Commissioner for Patents
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THE COMMISSIONER IS AUTHORIZED
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Sir:

Attached hereto is a check in the amount of \$1,360.00 to cover Patent Office fees relating to filing the following attached papers:

Request for Continued Examination (RCE) \$790.00

Petition for Extension of Time \$570.00

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Respectfully submitted,

Norio KIMURA et al.

By

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